

**FOR INFORMATION ONLY:
DO NOT MANUFACTURE
PARTS TO THIS DRAWING**

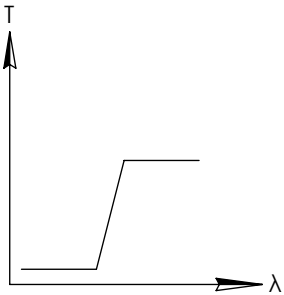
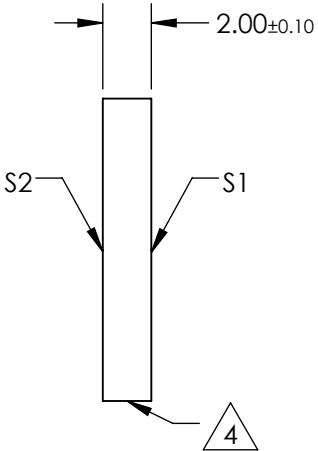
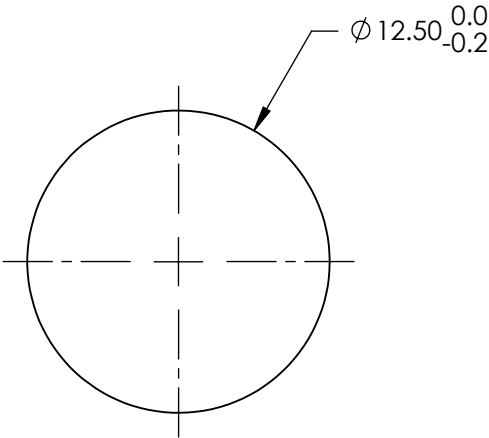
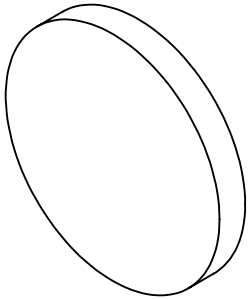
NOTES:

1. SUBSTRATE: UV FUSED SILICA
2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 arcsec
3. COATING (APPLY ACROSS COATING APERTURE)
S1: HARD DIELECTRIC SPUTTERED
T(avg): $\geq 91\%$ FROM 433 - 1650nm @ 0° AOI
T(avg): $\leq 0.01\%$ FROM 200 - 415nm @ 0° AOI
T(abs): =50% FOR 425 \pm 4.25nm @ 0° AOI

S2: SINGLE LAYER MgF2

 FINE GRIND SURFACE

5. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS
APPLY ACROSS CLEAR APERTURE
6. TRANSMITTED WAVEFRONT DISTORTION, RMS: $\leq \lambda/4$ @ 633nm (prior to coating)
7. ROHS COMPLIANT



LONGPASS FILTER

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2
SHAPE	PLANO	PLANO
SURFACE QUALITY	60-40	60-40
CLEAR APERTURE	>80%	>80%
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

 **Edmund Optics®**



ALL DIMS IN

mm

TITLE

Ø12.5mm, 425nm, HIGH PERFORMANCE
LONGPASS FILTER

DWG NO

84736

SHEET
1 OF 1